

Docket No.: 4425-320

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re Application of | : |
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| Chien-Hsin LAI <i>et al.</i> | : Confirmation No. 3535 |
| | : |
| U.S. Patent Application No. 10/659,258 | : Group Art Unit: 1763 |
| | : |
| Filed: September 11, 2003 | : Examiner: Karla A Moore |

For: PLASMA APPARATUS AND METHOD CAPABLE OF ADAPTIVE IMPEDANCE
MATCHING

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of September 12, 2006, please amend the above-identified application as follows: